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INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT: Lee D. Bergerson et al.

FILING DATE: January 5, 2001

GROUP: 3616

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
EC	6 0 0 0 2 8 7	Dec. 14, 1999	Menzel ✓	1	1	
EC	6 0 2 8 3 4 3	Feb. 22, 2000	Chan et al. ✓	1	1	
EC	6 1 4 9 1 9 0	Nov. 21, 2000	Galvin et al. ✓			

RECEIVED

APR 07 2003

GROUP 3600

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EC	1	MEMS "Virtual Learning Cybercenter and E(du) - Pages", "So What are these MEMS?"; "MEMS Overview from MCNC". ✓					
EC	1	"MEMS, Microengineering and Aerospace Systems", S. W. Janson and H. Helvajian, Center for Microtechnology, The Aerospace Corporation, Los Angeles, CA; K. Breuer, Aero/Astro Department, MIT, Cambridge, MA ✓					

EXAMINER

ERIC CULBRETH

DATE CONSIDERED

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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; -  
Draw line through citation if not in conformance and not considered. Include copy of this form with next  
communication to the patent applicants' attorney.